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TRANSMITTAL LETTER
(General - Patent Pending)

Docket No.
113184-114

In Re Application of: Hiroshi, et al.

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/563,630	January 6, 2006	Unknown	24573	Unknown	Unknown

Title: NITRIDE SEMICONDUCTOR DEVICE AND METHOD FOR PREPARATION THEREOF

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Preliminary Amendment (4 pgs.);
Replacement Drawings (2 sheets); and
Return Receipt Postcard

in the above identified application.

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Dated: February 27, 2006

Thomas C. Basso
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on	
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